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Examiner Initials	Cite No.¹	U.S. Patent Document	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document	Pages, Columns, Lines, Where Releva Passages or Relevant Figures Appear
		Number Kind Code (if known)		MM-DD-YYYY	
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Examiner	Cite No.'	Foreign Patent Document Kind Code ³ Office ³ Number ⁴ (if known)			Ī	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁴
Initials*							Document MM-DD-YYYY		
	+	JР	05-05515	9	7		03/05/1993		Abst.
		JP	2001-267	266			09/28/2001		Abst.
			0	THER PR	IOR A	RT – NON PATENT LITE	RATURE DOCUMENTS		
Examiner Initials	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.). date, page(s), volume-issue number(s), publisher, city and/or country where published.							
		Specification, claims, abstract and drawings of U.S. Patent Application Serial No. 10/345,401 entitled Method of Introducing Ion and Method of Manufacturing Semiconductor Device filed January 16, 2003							
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